## Application Number Docket Number (Optional) END920030002US1 Applicant(s) INFORMATION DISCLOSURE CITATION T. C. Krywanczyk et al. (Use several sheets if necessary) Filing Date Group Art Unit Herewith **U.S. PATENT DOCUMENTS** FILING DATE EXAMINER CLASS SUBCLASS DOCUMENT NUMBER DATE NAME REF INITIAL IF APPROPRIATE 250/459.1 06/03/85 4,651,011 03/17/87 Ors et al. 522/99 05/31/89 09/10/91 DeVoe et al. 5,047,444 427/8 12/30/94 09/17/96 Chang et al. 5,556,663 250/474.1 05/23/96 5,712,485 01/27/98 Broer et al. FOREIGN PATENT DOCUMENTS REF CLASS SUBCLASS DOCUMENT NUMBER DATE COUNTRY YES NO gu 1. JP9-075838 07/03/96 OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Furukawa Review, No. 22, "Development of Anti-static UV-tapes for Semiconductor Processing", by Y. Morishima et al., pgs. 1-5 Inttaled because no Cej **BEST AVAILABLE COPY** DATE CONSIDERED **EXAMINER**

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.